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APPLICATION NO.	FILING DATE	FIRST NAMED INVENTOR	ATTORNEY DOCKET NO.	CONFIRMATION NO.
10/531,007	10/13/2005	Fedja Bobanovic	920602-99281	2701
	7590 04/23/201 [.] IORNBURG LLP	EXAMINER		
P.O. BOX 2786	,	NGUYEN, THONG Q		
CHICAGO, IL 60690-2786			ART UNIT	PAPER NUMBER
			2872	
			NOTIFICATION DATE	DELIVERY MODE
			04/23/2010	ELECTRONIC

Please find below and/or attached an Office communication concerning this application or proceeding.

The time period for reply, if any, is set in the attached communication.

Notice of the Office communication was sent electronically on above-indicated "Notification Date" to the following e-mail address(es):

Patent-ch@btlaw.com

	Application No.	Applicant(s)			
	10/531,007	BOBANOVIC ET AL.			
Office Action Summary	Examiner	Art Unit			
	Thong Nguyen	2872			
The MAILING DATE of this communication app Period for Reply	pears on the cover sheet with the c	orrespondence address			
A SHORTENED STATUTORY PERIOD FOR REPL' WHICHEVER IS LONGER, FROM THE MAILING D. - Extensions of time may be available under the provisions of 37 CFR 1.1 after SIX (6) MONTHS from the mailing date of this communication. - If NO period for reply is specified above, the maximum statutory period - Failure to reply within the set or extended period for reply will, by statute Any reply received by the Office later than three months after the mailing earned patent term adjustment. See 37 CFR 1.704(b).	ATE OF THIS COMMUNICATION 36(a). In no event, however, may a reply be time will apply and will expire SIX (6) MONTHS from a cause the application to become ABANDONE	l. lely filed the mailing date of this communication. (35 U.S.C. § 133).			
Status					
Responsive to communication(s) filed on <u>24 F</u> This action is FINAL . 2b) ☐ This Since this application is in condition for alloward closed in accordance with the practice under E	action is non-final. nce except for formal matters, pro	secution as to the merits is			
Disposition of Claims					
4) Claim(s) 32-62 is/are pending in the applicatio 4a) Of the above claim(s) 35-47 and 50-62 is/a 5) Claim(s) is/are allowed. 6) Claim(s) 32-34,48 and 49 is/are rejected. 7) Claim(s) is/are objected to. 8) Claim(s) are subject to restriction and/o Application Papers 9) The specification is objected to by the Examine 10) The drawing(s) filed on is/are: a) accomplicant may not request that any objection to the Replacement drawing sheet(s) including the correct	re withdrawn from consideration. r election requirement. er. epted or b) □ objected to by the Edrawing(s) be held in abeyance. See	e 37 CFR 1.85(a).			
11)☐ The oath or declaration is objected to by the Examiner. Note the attached Office Action or form PTO-152.					
Priority under 35 U.S.C. § 119					
 12) Acknowledgment is made of a claim for foreign priority under 35 U.S.C. § 119(a)-(d) or (f). a) All b) Some * c) None of: 1. Certified copies of the priority documents have been received. 2. Certified copies of the priority documents have been received in Application No 3. Copies of the certified copies of the priority documents have been received in this National Stage application from the International Bureau (PCT Rule 17.2(a)). * See the attached detailed Office action for a list of the certified copies not received. 					
Attachment(s) 1) Notice of References Cited (PTO-892) 2) Notice of Draftsperson's Patent Drawing Review (PTO-948) 3) Information Disclosure Statement(s) (PTO/SB/08) Paper No(s)/Mail Date 2/16/10.	4) Interview Summary Paper No(s)/Mail Da 5) Notice of Informal P 6) Other:	te			

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DETAILED ACTION

Continued Examination Under 37 CFR 1.114

1. A request for continued examination under 37 CFR 1.114, including the fee set forth in 37 CFR 1.17(e), was filed in this application after final rejection. Since this application is eligible for continued examination under 37 CFR 1.114, and the fee set forth in 37 CFR 1.17(e) has been timely paid, the finality of the previous Office action has been withdrawn pursuant to 37 CFR 1.114. Applicant's submission filed on 2/26/2010 has been entered.

Response to Amendment

- 2. The present Office action is made in response to the amendment filed on 2/24/2010.
- 3. It is noted that in the amendment, applicant has amended claims 32, 34 and 48. There is not any claim being added into or canceled from the application. The pending claims are claims 32-62 in which claims 32-34 and 48-49 are examined in this Office action and claims 35-47 and 50-62 have been withdrawn from further consideration as being directed to non-elected inventions. Note that claims 1-31 were canceled in the Pre-amendment of 4/12/2005.

Claim Rejections

4. The rejection to claim 34 as set forth in the previous Office action have been overcome by the amendments to the claim as provided in the amendment of 2/24/10.

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Claim Rejections - 35 USC § 103

5. The text of those sections of Title 35, U.S. Code not included in this action can be found in a prior Office action.

6. Claims 32 and 48 are rejected under 35 U.S.C. 103(a) as being unpatentable over Endo et al (of record) in view of Wolf et al (U.S. Patent No. 4,972,258).

Endo et al disclose a confocal microscope. The confocal microscope as described in paragraphs [0220]+ and shown in figs. 19+ comprises the following features: a) a means for mounting a specimen (40) which is able to move along an optical axis; b) a light source system (30, 32) for providing light to illuminate the specimen; c) a confocal scanning system (102, 42, 96) for directing light from the light source system to the specimen in one direction and for directing light reflected from the specimen to a detecting system in other direction. The scanning disk (102) is rotated to guide light emitted from the disk to scan repeatedly an area of interest of the specimen; d) a detecting system (44, 46) having a charged coupled device (46) which comprises a plurality of spatially distinct sensitive regions for receiving light reflected from the specimen after passed through the apertures of the scanning disk (102); and d) a control system (86, 60a-b, 78, 104, 106) having a host computer (86) and a controller (78) for controlling the operation of the charged coupled device (46), the scanning disk (102) on the basis of input signals provided by the photodetectors (60a, 60b), synchronizing signal generator (104), computer (86), ... so that the time the light from the specimen incidents on the charge coupled device is synchronized with

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the scanning time of the scanning disk. See paragraphs [0226], [0248], for example. It is also noted that the signals from the charged coupled device is displayed on a monitor (58), see paragraphs [0221]-[0222].

The only feature missing from the microscope provided by Endo et al is that they do not explicitly state that the control circuit is a state machine having a state counter, a memory and a duration downcounter which receives a clock signal. However, the use of a control system having a host computer and a controller having counters, memory, clock signals, and other computerized elements to control the operations of optical elements of a microscope based on the outputs from detecting elements is known to one skilled in the art as can be seen in the microscope provided by Wolf et al. In particular, Wolf et al disclose a microscope (10) having an illumination system, a scanning system and a detecting system, see columns 5-7 and figs. 1-2, wherein the detecting system comprises a plurality of detectors, a computer, a frame storage control circuit,...which are connected to receive and send controlled signals to control the operations of the optical elements constituted the microscope, see columns 21+ and figs. 9+. Thus, it would have been obvious to one skilled in the art at the time the invention was made to modify the microscope provided by Endo et al by using a detecting system having a plurality of detectors, a computer, a frame storage control circuit,...which are connected to receive and send controlled signals to control the operations of the optical elements constituted the microscope as suggested by Wolf et al for the purpose of control the operation of the optical

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elements to meet a particular set of conditions including the time to receive image of the detecting elements.

7. Claims 33-34 and 49 are rejected under 35 U.S.C. 103(a) as being unpatentable over Endo et al in view of Wolf et al as applied to claims 32 and 48 above and further in view of Morita et al (of record).

The combined product as provided by Endo et al and Wolf et al does not explicitly disclose a shutter disposed on the downstream of the light source system (30, 32) for controlling the light from illumination the specimen. Regarding to the feature regarding to a shutter disposed upstream of the charged coupled device, such feature is inherently known because any charged coupled device comprises a shutter disposed therein. It is also noted that Endo et al do not disclose the operation of the shutter of the charged coupled device in relation to the operation of the shutter disposed downstream of the light source system. However, the use of two shutters wherein one is disposed on the downstream of a light source and the other is disposed upstream of a charged coupled device wherein the two shutters are connected to a control system so that their operations are related to each other is known to one skilled in the art as can be seen in the optical device provided by Morita et al. In particular, Monita et al disclose an optical device having an illumination system for providing light to illuminate an object and a detecting system for receiving light reflected from the object. The illumination system comprises a shutter (17) in the form of an acousto-optic element, see paragraph [0052] and the detecting system

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comprises a shutter wherein both shutters are connected by the control system so that their operations are synchronously related to each other. See paragraph [0062]-[0063]. Thus, it would have been obvious to one skilled in the art at the time the invention was made to modify the combined product as provided by Endo et al and Wolf et al by utilizing shutters in the illumination system and the detecting system as suggested by Monita et al for the purpose of controlling the operations of the shutters and for reducing errors to the images received by the detecting system.

Response to Arguments

8. Applicant's arguments with respect to claims 32-34 and 48-49 as provided in the amendment of 2/24/10 have been considered but are moot in view of the new grounds of rejection.

Conclusion

- 9. The prior art made of record and not relied upon is considered pertinent to applicant's disclosure. The foreign reference JP 2000-275534A has been lined-through because the reference was listed in the form PTO-1449 filed on 10/13/09 and has been considered by the examiner. A copy of the mentioned IDS with the examiner's initials was mailed to applicant on 121/30/09.
- 10. Any inquiry concerning this communication or earlier communications from the examiner should be directed to Thong Nguyen whose telephone number is (571) 272-2316. The examiner can normally be reached on M-F.

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If attempts to reach the examiner by telephone are unsuccessful, the examiner's supervisor, Stephone B. Allen can be reached on (571) 272-2434. The fax phone number for the organization where this application or proceeding is assigned is 571-273-8300.

Information regarding the status of an application may be obtained from the Patent Application Information Retrieval (PAIR) system. Status information for published applications may be obtained from either Private PAIR or Public PAIR. Status information for unpublished applications is available through Private PAIR only. For more information about the PAIR system, see http://pair-direct.uspto.gov. Should you have questions on access to the Private PAIR system, contact the Electronic Business Center (EBC) at 866-217-9197 (toll-free). If you would like assistance from a USPTO Customer Service Representative or access to the automated information system, call 800-786-9199 (IN USA OR CANADA) or 571-272-1000.

/Thong Nguyen/ Primary Examiner, Art Unit 2872